Search Notes					

Application/Control No.	Applicant(s)/Patent under Reexamination
10/767,167	MIURA ET AL.
Examiner	Art Unit
Matthew L. Reames	2891

SEARCHED			
Class	Subclass	Date	Examiner
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			-

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examine
			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
Mach-Zender Inforemeter same silicon (EAST)	10/8/2007	MLR	
·.			